ROUII will give you the Advantage

RAD-3000F/8



Outline

- -Fully-automatic BG Tape remover for single wafer.
- After alignment, UV is irradiated when necessary, and back grinding tape is removed by attaching heat seal on the periphery of the wafer, fixed with heater.

Option ·Host Communication Function (Communication Format :

Conforms to SECS-I and HSMS/Software: Conforms to GEM)

Suitable Tapes ·BG Tape : Adwill E series, P series

Facility

Power Supply Voltage : AC200-230V $\pm 10\%$

(AC190-253V)

Unit:mm

Frequency : 50/60Hz
Phase : single phase
Power consumption : 5.0kW

Air Supply Air pressure : 0.5-0.8MPa

Air consumption : >150L/min (ANR)

Vacuum Supply Vacuum pressure : >-80kPa

Applicable Wafer Size 125mm, 150mm, 200mm

Size Width: 1,190mm

Depth: 1,195mm Height: 1,550mm

(excluding the signal tower)

Weight 1,000kg

UPH 80wafers/hour

The above processing capacity is based on following conditions:

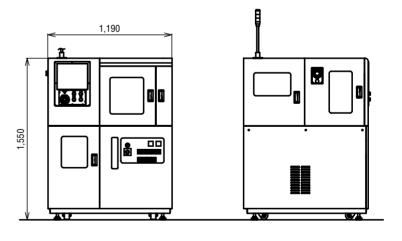
Wafer : 200mm diameter non-polished mirror wafer

Back grinding tape: E-6142S from LINTEC

External View

1,190 R585 R626

Top View



Front View Left Side View

Contact:Advanced Materials Operations

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